AMENDMENT TRANSMITTAL LETTER (Small Entity) Applicant(s): Scherer et al.						Docket No. CIT.PAU.01		
Serial No.	Filling	g Date		Examiner			Group Art Unit	
10/068,283	JUM   E/ '''''	ry 5, 2002		R. McDonald			1753	
- V. V ,_	(%) NET	1y 5, 2002	<u></u>			<u> </u>		
Invention:	Invention:							
DRY ETCHING AND MIRROR DEPOSITION PROCESSES FOR SILICONE ELASTOMER								
	TC	THE COMMISSI	IONEF	R FOR PATENTS:				
Transmitted herewith is an amendment in the above-identified application.  Small Entity status of this application has been established under 37 CFR 1.27 by a verified statement previously submitted.  □ A verified statement to establish Small Entity status under 37 CFR 1.27 is enclosed.  The fee has been calculated and is transmitted as shown below.								
CLAIMS AS AMENDED								
	CLAIMS REMAINING	HIGHEST#		NUMBER EXTRA	2475		ADDITIONAL	
	AFTER AMENDMENT	PREV. PAID FOR	R _	CLAIMS PRESENT	RATE	_1	FEE	
TOTAL CLAIMS	20 -	20 =			x \$9.	.00	\$0.00	
INDEP. CLAIMS	5 -	5 =	=	0	x \$43	3.00	\$0.00	
Multiple Depender	nt Claims (check if appl	licable)					\$0.00	
		TOTAL ADDITIO	NAL F	FEE FOR THIS AME	ENDMENT	-	\$0.00	
No additional fee is required for amendment.  ☐ Please charge Deposit Account No. in the amount of ☐ A check in the amount of to cover the filing fee is enclosed. ☐ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 01-1960 ☐ Any additional filing fees required under 37 C.F.R. 1.16. ☐ Any patent application processing fees under 37 CFR 1.17. ☐ Dated: June 21, 2004 ☐ Certify that this document and fee is being deposited on ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐								
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Signature of Person Mailing Correspondence

Jo Ann Breen

Typed or Printed Name of Person Mailing Correspondence

Patent CIT.PAU.01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Scherer et.al.

Serial No.: 10/068,283

Filed: Feb. 5, 2002

For: Dry Etching and Mirror

**Deposition Processes for Silicone** 

**Elastomer** 

**Examiner: R.McDonald Group Art Unit: 1753** 

## **AMENDMENT**

Hon. Commissioner of Patents and Trademarks Washington DC 20231

Sir:

In reply to the Office June 7, 2004, please consider the following remarks and enter the following amendments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 this paper.

Remarks begin on page 7 of this paper.